

Electronic Supplementary Information

Facile Organic Surfactant Removal of Various Dimensional Nanomaterials Using Low-Temperature Photochemical Treatment

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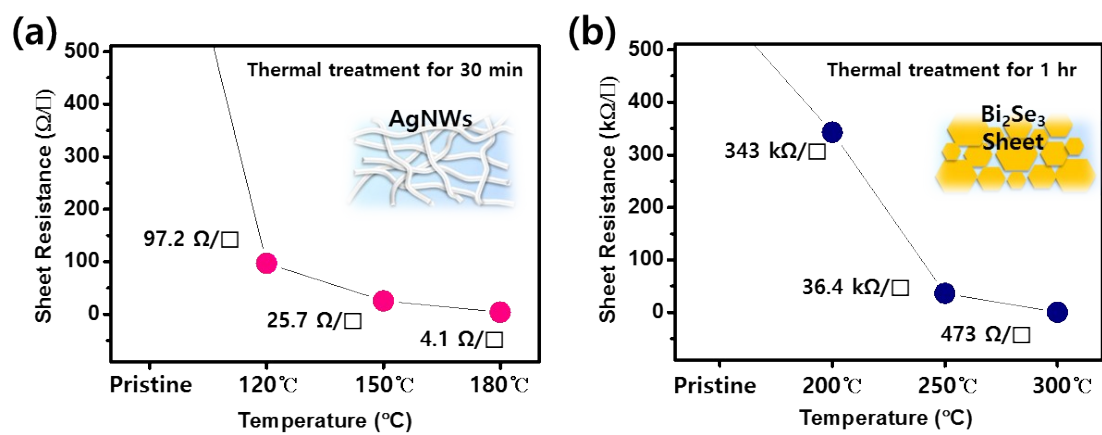


Figure S1. Sheet Resistance of thermal treated (a) AgNWs, and (b) Bi_2Se_3 NSs

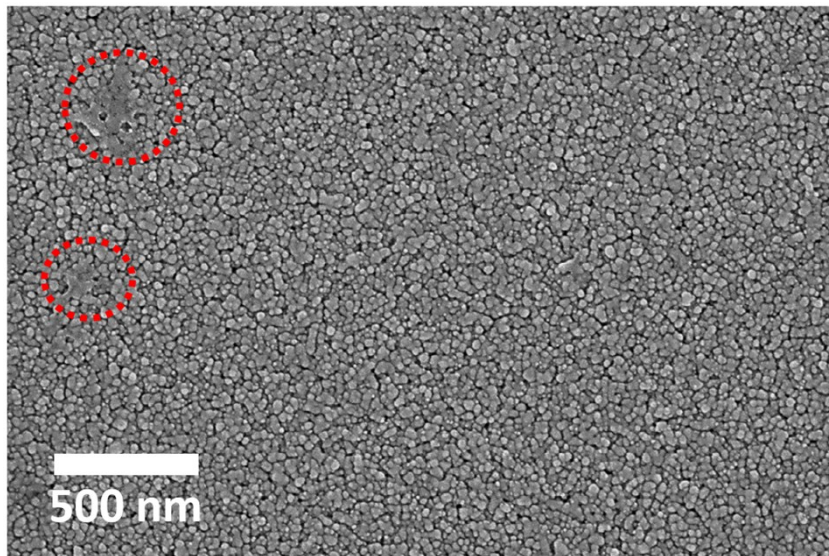


Figure S2. FESEM image of thermally treated AgNPs with oleylamine capping ligand (OAm-AgNPs) at 150°C. Inner circle shows residual organic surfactants.

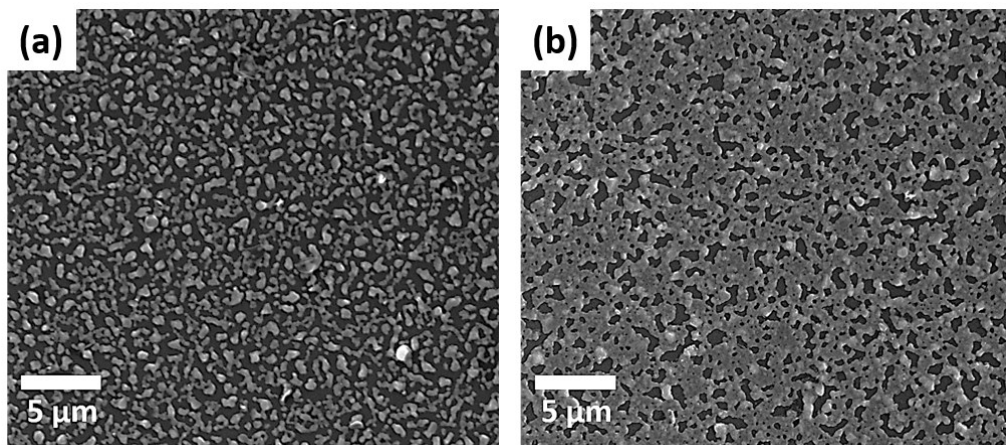


Figure S3. FESEM images of aggregation phenomenon of OAm-AgNPs at 200°C (a: center, b: edge). The aggregation phenomenon shifted toward the side edge of the substrate.

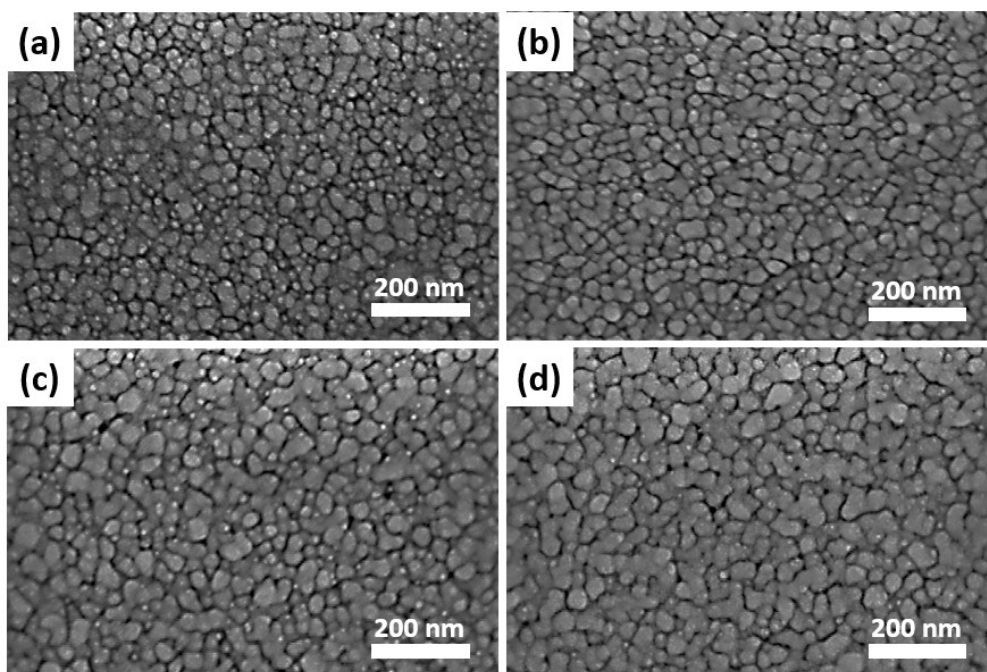


Figure S4. FSEM images of photochemically treated OAm-AgNPs for various DUV exposure times (a: DUV-30 min, b: DUV-60 min, c: DUV-90 min, d: DUV-120 min).

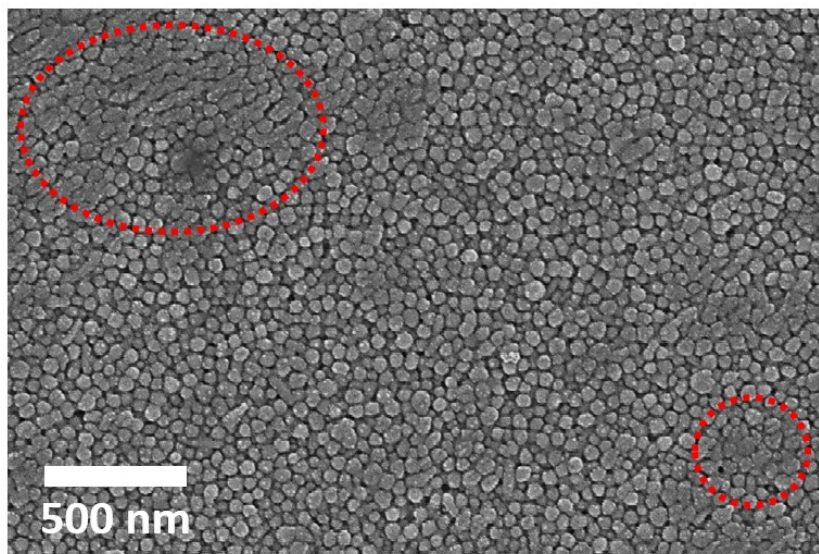


Figure S5. FESEM image of thermally treated AgNP with PVP capping ligand at 120°C.

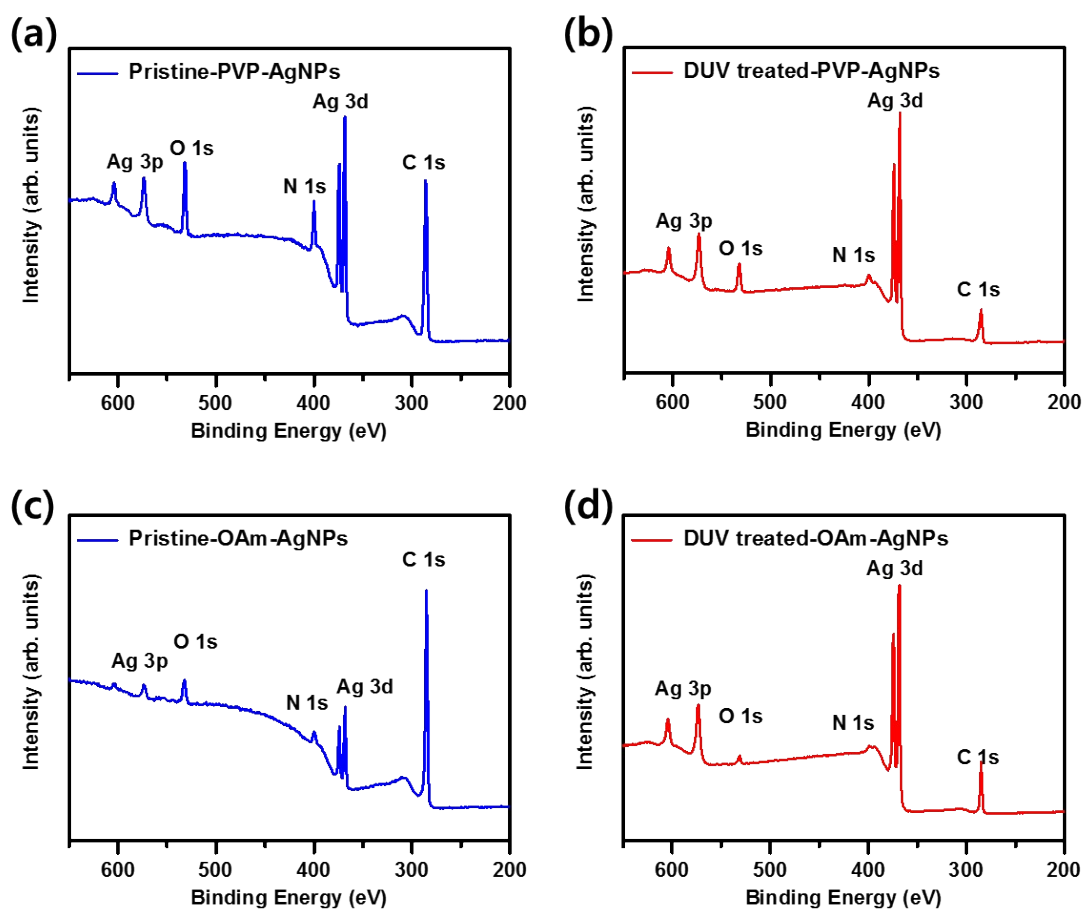


Figure S6. X-ray photoelectron spectroscopy analysis of (a) pristine-PVP-AgNPs, (b) DUV-treated PVP-AgNPs, (c) pristine-OAm-AgNPs, and (d) DUV-treated OAm-AgNPs.

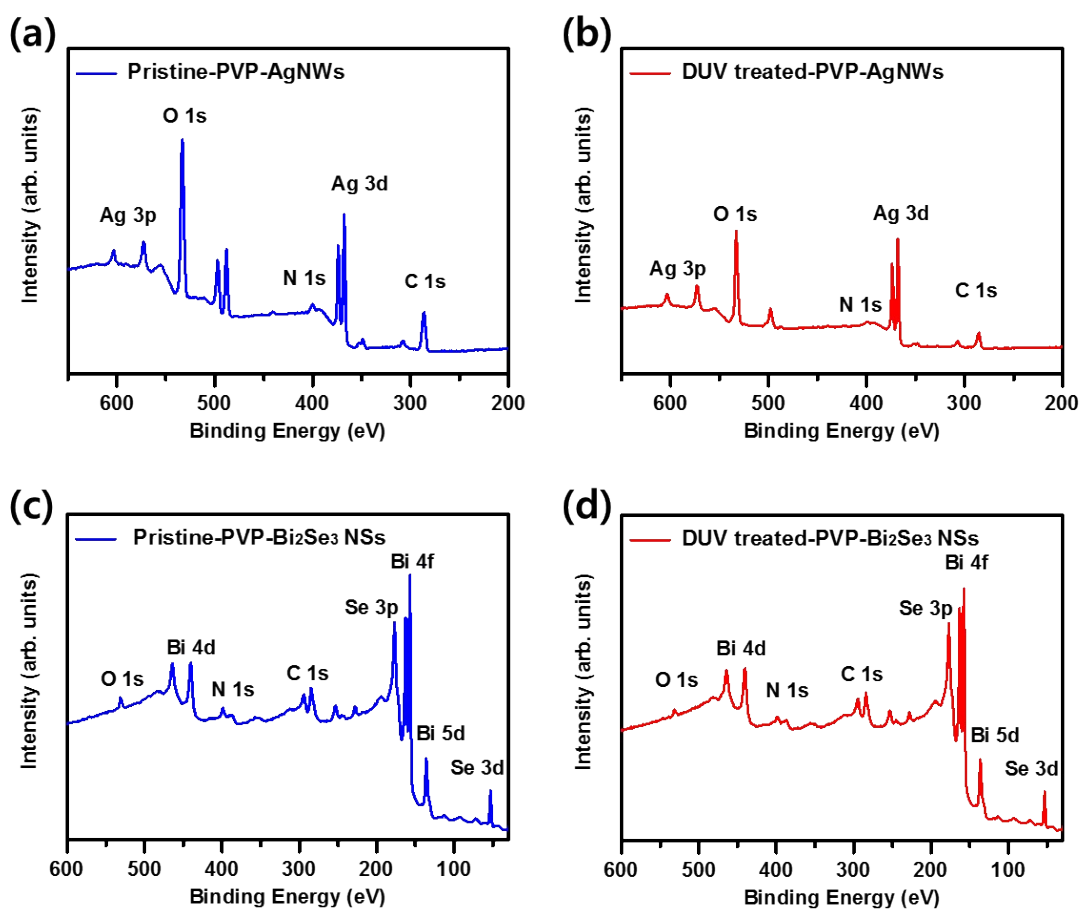


Figure S7. X-ray photoelectron spectroscopy analysis of (a) pristine-PVP-AgNWs, (b) DUV-treated PVP-AgNWs, (c) pristine-PVP-Bi₂Se₃ NSs, and (d) DUV-treated PVP-Bi₂Se₃ NSs.